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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Etienne QUESNEL et al.

Group Art Unit: 1756

Application No.: 10/816,911

Filed: April 5, 2004

Docket No.: 119364

For: PROCESS DESIGNED TO PREVENT DEPOSITION OF CONTAMINATING  
PARTICLES ON THE SURFACE OF A MICRO-COMPONENT, MICRO-  
COMPONENT STORAGE DEVICE AND THIN LAYER DEPOSITION DEVICE

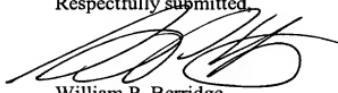
**SECOND STATUS INQUIRY LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please telephone our firm's Patent Application Filing Department at 703-836-6400 with  
the status of the above-identified patent application, including an indication as to when the next  
communication can be expected.

Respectfully submitted,



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WPB:SPC/amb

Date: April 2, 2007

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